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Withdrawer

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File Folder TECHNOLOGY TRANSFER-MISC (01/01/1981-03/31/1981

FOIA

F02-0083/01

Box Number 28

PRADOS

2813

ID	Doc Type	Document Description	No of Pages	Doc Date	Restrictions
179849	FOLDER	NOTES AND MEMOS	22	3/16/1981	B1

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179849 FOLDER

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**DEFENSE DEPARTMENT'S INITIAL MILITARILY CRITICAL
TECHNOLOGIES LIST AND DEPARTMENT OF ENERGY'S LIST
OF ENERGY RELATED MILITARILY CRITICAL TECHNOLOGIES**
(45 Fed. Reg. 65014, 65152, Oct. 1, 1980)
(For related news item, see page A-2.)

Initial Militarily Critical Technologies List

AGENCY: Office of the Secretary of Defense.

ACTION: Notice.

SUMMARY: The Department of Defense is submitting the following list of critical technologies whose acquisition by potential adversaries would be detrimental to national security. This list was mandated by the Export Administration Act of 1979 in order to provide guidance on export control matters.

FOR FURTHER INFORMATION CONTACT: Deputy Under Secretary of Defense of Research and Engineering, International Programs and Technology, Office of Technology Trade, Room 3B1060, Washington, D.C. 20301, Telephone: 202 694-4777.

M. S. Healy,
OSD Federal Register Liaison Officer,
Washington Headquarters Services,
Department of Defense.
26 September 1980.

Initial Militarily Critical Technologies List

The Initial Militarily Critical Technologies List has been produced by the Department of Defense in response to Section 5(d) of the Export Administration Act of 1979, which states:

(2) The Secretary of Defense shall bear primary responsibility for developing a list of militarily critical technologies. In developing such list, primary emphasis shall be given to—

(A) arrays of design and manufacturing know-how,

(B) keystone manufacturing, inspection, and test equipment, and

(C) goods accompanied by sophisticated operation, application, and maintenance know-how

which are not possessed by countries to which exports are controlled under this section and which, if exported, would permit a significant advance in a military system of any such country.

(3) The list referred to in Paragraph (2) shall be sufficiently specific to guide the determination of any official exercising export licensing responsibilities under this Act.

(4) The initial version of this list referred to in Paragraph (2) shall be completed and published in an appropriate form in the Federal Register not later than October 1, 1980.

The Initial List has been developed by the Department of Defense, with the cooperation of other agencies of the U.S.

Government and U.S. industry, to identify those elements of technology the export of which to potential adversaries could increase their military capabilities to the detriment of U.S. national security. The Department of Defense will periodically review and, as necessary, update and amend the Initial List as part of its continuing responsibility to protect the technology leadtime of the U.S. as compared to its adversaries in the application of advanced technologies to military capabilities.

The Table of Contents for the Initial List is presented below. Detailed specifications of the list and the supportive documentation are currently undergoing Government security review. Subsequently, an appropriately modified unclassified List as refined and elaborated by the Department of Defense in cooperation with other interested government agencies, will be submitted for inclusion as part of the Commodity Control List (CCL), after consultation with our Allies, for the concurrence of the Secretary of Commerce, in accordance with the procedures stated in Section 5(c)(2) of the Export Administration Act of 1979.

The technologies identified in the Initial List contribute to the development, production or utilization of items being controlled for national security purposes on the current CCL. The Initial List also identifies certain technologies that contribute to items on the Munitions List which have present or potential civil application.

The commodities described in the list are limited to equipment and materials so far identified as either critical to the development, production or utilization of end-items of concern or goods which would convey information concerning these activities. The list does not address end-items of intrinsic military utility; such items remain under the control of the CCL and the Munitions List. The Department of Defense may recommend that certain items on the Initial List be controlled through the Munitions List (ITAR), while certain items presently on the CCL may be recommended for decontrol.

The Initial List and associated detailed documentation of list items shall provide guidance within the Department of Defense for the review of those export license applications that particularly involve the transfer of know-how to Warsaw Pact countries. The application of the Initial List by the Department of Defense to the export of

equipment will be in a manner commensurate with the CCL and the Export Administration Regulations, and will not supersede the technical definitions of the CCL until further refinement dictates suitable specification revisions.

The Initial List is itself not intended as a control list, nor is it intended as a substitute for, or an addition to, the current CCL, nor does it supplant the case-by-case review of export license applications. Further, the specificity with which the technology elements within these areas are identified in many cases needs further refinement for control decisions. Moreover, it should not be construed that technical data not listed should be freed from control.

In the Initial List, technologies are defined under four general categories:

A. Arrays of Know-How (including design and manufacturing know-how) are the know-how and related technical information required to achieve a significant development, production or utilization purpose. Such know-how includes services, processes, procedures, specifications, design data and criteria, and testing techniques.

B. Keystone Equipment (including manufacturing, inspection or test equipment) is that equipment specifically necessary for the effective application of a significant array of technical information and know-how.

C. Keystone Materials are materials specifically necessary for the effective application of a significant array of technical information and know-how.

D. Goods Accompanied by Sophisticated Know-How are goods, 1. the use of which requires the provision (disclosure) of a significant array of technical information and know-how (including operation, application or maintenance know-how), and/or 2. for which embedded know-how is inherently derivable by reverse engineering, or is revealed by use of the goods.

Contents

- 1.0 Computer Networks Technology
- 2.0 Computer Technology
- 3.0 Software Technology
- 4.0 Automated Real-time Control Technology
- 5.0 Materials Technology
- 6.0 Directed Energy Technology
- 7.0 Semiconductor and Electric Component Technology
- 8.0 Instrumentation Technology
- 9.0 Telecommunications Technology

10.0 Communication, Navigation,
Guidance and Control Technology
11.0 Microwave Technology
12.0 Vehicular Technology
13.0 Optical and Laser Technology
14.0 Sensor Technology
15.0 Undersea Systems Technology
16.0 Chemical Technology
17.0 Nuclear Specific Technology
(Draft being finalized with the
Department of Energy for later
publication)

1.0 Computer Networks Technology

1.1 Network Architecture

1.2 Implementation Technologies

2.0 Computer Technology

2.1 System Architecture Technology

2.1.1 General System Architecture
Technology

2.1.2 Processor Architecture
Technology

2.1.3 Memory Hierarchy Technology

2.2 Systems Hardware Development
and Production Technology

2.2.1 Computer Hardware
Development Technology

2.2.2 Computer Hardware Production
Technology

2.2.3 Computer Manufacturing Control
System (CMCS) and Computer-
Assisted Manufacturing (CAM)
Technology

2.2.4 Interconnections Technology

2.2.5 Production Testing Technology

2.2.6 Computer Cooling Technology

2.2.7 Power Supply and Distribution
Technology

2.3 Digital Computer System
Utilization Technology

2.3.1 Computer-Assisted Servicing
(CAS) Technology

2.3.2 Computer Systems Configuration
Management Technology

2.3.3 Digital Computer Security
Technology

2.3.4 Computer-Assisted Training/
Simulation Technology

2.4 Logic and High-Speed Memory
Assembly Technology

2.4.1 Semiconductor Logic and Memory
Assembly Technology

2.4.2 Magnetic Core Memory
Technology

2.4.3 Josephson Junction Technology
2.4.4 Charge-Coupled Device (CCD)
Memory Technology

2.4.5 Magnetic Bubble Logic and
Memory Technology

2.4.6 Magnetic Cross-Tie Memory
Technology

2.4.7 Plated-Wire Memory Technology

2.4.8 Microprocessor Technology

2.5 Storage Technology

2.5.1 Magnetic Disc Storage
Technology

2.5.1.1 Magnetic Disc Read/Write
Head Technology

2.5.1.2 Magnetic Disc Recording Media
Technology

2.5.1.3 Winchester Disc Technology

2.5.1.4 Flexible Disc Drive Technology

2.5.2 Magnetic Tape Storage
Technology

2.5.2.1 Conventional Magnetic Tape
Drive Technology

2.5.2.2 Cartridge/Cassette Technology

2.5.3 Other Storage Technology

2.5.3.1 Electron Beam Memory
Technology

2.5.3.2 Optical Cryogenic Memory
Technology

2.5.3.3 Holographic/Laser Memory
Technology

2.5.3.4 Video Disc Digital Recording
Technology

2.5.3.5 Archival Magnetic Tape
Memory Technology

2.6 Digital Computer Display and
Peripheral Technology

2.6.1 Alphanumeric and Graphic
Terminal Technology

2.6.2 Peripheral Technology

2.6.2.1 Digital Flat-Head Technology

2.6.2.2 Non-Impact Line Printer
Technology

2.7 Analog and Hybrid Computer
Technology

2.8 Other Related Technology

2.8.1 Speech Processing Technology

2.8.2 Artificial Intelligence Technology

3.0 SOFTWARE TECHNOLOGY

3.1 Development Environment
Technology

3.1.1 Software Life-Cycle Management
Technology

3.1.2 Software Library Data Base
Technology

3.1.3 Software Development Tool
Technology

3.1.4 Formal Methods and Tools for
Developing Trusted Software
Technology

3.2 Operations and Maintenance
Technology

3.2.1 Maintenance of Large Software
Product Technology

3.3 Application Software Technology

3.3.1 Secure Software Technology

3.3.2 Large Self-Adapting Software
System Technology

4.0 AUTOMATED REAL-TIME CONTROL TECHNOLOGY

4.1 Utilization of Digital Processing
Technology

4.2 Analog and Hybrid Computing
Technique Technology

4.3 Display Technology

4.4 Related Software Technology

5.0 MATERIALS TECHNOLOGY

5.1 Metals and Alloys Technology

5.1.1 Magnetic and Amorphous Metals
Technology

5.1.2 Nickel-Based Alloys Technology

5.1.3 Titanium Alloys Technology

5.1.4 High-Temperature Coatings
Technology for Superalloys and
Titanium

5.1.5 Niobium (Columbium) Alloys
Technology

5.1.6 Molybdenum Alloys Technology

5.1.7 Tungsten Alloys Technology

5.1.8 Casting and Coating Technology
of Intricate Hollow Superalloy
Shapes

5.1.9 Plasma Spraying Technology

5.1.10 Advanced Powder Metallurgy
Technology

5.1.11 Superplastic Forming/Diffusion
Bonding (SPF/DB) Technology

5.1.12 Titanium, Nickel, and Iron
Aluminides Technology

5.1.13 Superconducting Materials
Technology

5.1.14 Pressure Pipe Fittings
Technology

5.2 Advanced Composites Technology

5.2.1 Fibers and Filamentary Materials
Technology

5.2.2 Filament Winding, Tape Laying,
and Interlacing Technology

5.2.3 Advanced Organic Matrix
Composites Technology

5.2.4 Metal- and Graphite-Matrix
Composites Technology

5.2.5 Ceramics Technology

5.2.6 Superalloy Composites
Technology

5.3 Processing and Forming
Technologies

5.3.1 Hot Isostatic Pressing (HIP)
Technology

5.3.2 High-Temperature Press
Technology

5.3.3 Isothermal Rolling Mill
Technology

5.3.4 Isothermal Metal Working
Technology

5.3.5 High-Temperature Furnace and
Coating Unit Technology

5.3.6 Numerically Controlled Machine
Tools Technology

5.3.7 Precision Turning Machines
Technology

5.3.8 Spin- and Flow-Forming
Machines Technology

5.3.9 High Vacuum Technology -
(Pumps)

5.3.10 Laser Processing Technology

5.3.11 High Performance Welding
Technology

5.3.12 Fracture Analysis,
Nondestructive Evaluation (NDE),
and Control Technology

5.3.13 Test Equipment for Integrated
Structural Testing Technology

6.0 Directed Energy Technology

6.1 High Energy Laser (HEL) Lasers
Technology

6.1.1 High Energy Laser Technology

- 6.1.2 Minor and Optical Device Technology
- 6.1.3 Beam Pointing and Control Technology
- 6.1.4 Mounting Subsystem Technology
- 6.1.5 Beam-Targeting Coupling Technology
- 6.1.6 Beam Propagation Technology
- 6.2 Particle Beam Technology
 - 6.2.1 High-Current Particle Beam Generation Technology
 - 6.2.1.1 Post-Injection (Particle Beam Accelerator) Technology
 - 6.2.2 Short-Term Energy Generation Subsystem Technology
 - 6.2.3 Beam Propagation Technology
 - 6.2.4 Beam-Target Coupling Technology
 - 6.2.5 Beam Control Subsystem Technology
 - 6.2.6 Beam Neutralization Technology
- 6.3 Microwave Energy Transmission Technology
- 7.0 Semiconductor and Electronic Component Technology
- 7.1 Microcircuit Technology
 - 7.1.1 Wafer Preparation
 - 7.1.2 Epitaxy
 - 7.1.3 Oxidation
 - 7.1.4 Maskmaking
 - 7.1.5A Lithography-Resist Processing
 - 7.1.5B Lithography-Wafer Imaging
 - 7.1.6 Selective Removal
 - 7.1.7 Diffusion/Implantation
 - 7.1.8 Thin Film Deposition
 - 7.1.9 Assembly
 - 7.1.10 Testing
 - 7.1.11 Facilities
 - 7.1.12 IC Design
 - 7.1.13 Hybrid Microcircuits
 - 7.1.14 Microwave Microcircuits
- 7.2 Transistor, Diode, and Thyristor Technology
 - 7.2.1 Discrete Transistors
 - 7.2.2 Diodes
 - 7.2.3 Thyristors
- 7.3 Detector, Tube, Intensifier, and Cooler Technology
 - 7.3.1 Semiconductor Detectors
 - 7.3.2 Photomultiplier Tubes
 - 7.3.3 Image Intensifiers
 - 7.3.4 Thermoelectric Coolers
- 7.4 Acoustic Wave Device Technology
- 7.5 Thin Film Memory Device Technology
 - 7.5.1 Magnetic Bubble Memories
 - 7.5.2 Plated Wire Memories
 - 7.5.3 Cross-Tie Memories
- 7.6 Passive Component Technology
 - 7.6.1 Ferrite Materials
 - 7.6.2 Boundary Layer Monolithic Ceramic Capacitors
 - 7.6.3 Quartz Crystals
 - 7.6.4 Printed Circuit Boards
- 7.7 Cryogenic Component Technology
 - 7.7.1 Superconducting Digital Components

- 7.7.2 Superconducting RF Components
- 7.7.3 Cryogenic Coolers
- 7.8 Electronic Material Technology
 - 7.8.1 Bulk Indium Phosphide (InP)
 - 7.8.2 Bulk Gallium Arsenide (GaAs)
 - 7.8.3 Vapor Phase Epitaxy of $\text{In}_{1-x}\text{Ga}_x\text{P}_{1-x}\text{As}_x$ on InP
 - 7.8.4 Lead Lanthanum Zirconium Titanate (PZLT)
 - 7.8.5 Lead Zirconium Titanate ($\text{Pb}(\text{Zr,Ti})\text{O}_3$, PZT)
 - 7.8.6 MgO (Magnesium Oxide, Periclase)
 - 7.8.7 Thin Film Interference Coatings for Optics and Other Applications by Vacuum Deposition
 - 7.8.8 Sodium and Potassium Halides (NaF, NaCl, KCl, KBr, etc.)
 - 7.8.9 Thallium Bromiodide ($\text{TlBr}_2\text{I}_{1-x}$, KRS-5)
 - 7.8.10 Dehydrogen Phosphates (ADP, KDP, KD*P, CD*P, CD*A, etc.)
 - 7.8.11 Bismuth Silicon Oxide (BSO, $\text{Bi}_{12}\text{SiO}_{20}$) Bismuth Germanium Oxide (BGO, $\text{Bi}_{12}\text{GeO}_{20}$)
 - 7.8.12 Polyvalent Binary Fluorides (e.g., BaF_2 , CeF_3 , LaF_3 , ThF_4 , ZrF_4)
 - 7.8.13 Yttrifluorides (e.g., LiYF_4 , KY_2F_{10} , etc.)
 - 7.8.14 Niobates and Tantalates (e.g., LiNbO_3 , LiTaO_3 , KNbO_3)
 - 7.8.15 Neodymium Laser Hosts (especially YAG ($\text{Y}_3\text{Al}_5\text{O}_{12}$), but also including $\text{La}_2\text{Be}_2\text{O}_7$, $\text{NdP}_2\text{O}_{14}$, K_2NdLiF_6 , etc.)
 - 7.8.16 Lanthanum Chloride Laser Materials ($\text{LaCl}_3\text{Pr}^{3+}\text{Er}^{3+}$, etc.)
 - 7.8.17 Mercury Cadmium Telluride (bulk and thin films)
 - 7.8.18 Cadmium Telluride Crystals
 - 7.8.19 Lead Telluride (PbTe)
 - 7.8.20 Epitaxial Lead Tin Telluride and Lead Telluride (PbSnTe and PbTe)
 - 7.8.21 Lead Tin Selenide ($\text{Pb}_{1-x}\text{Sn}_x\text{Se}$)
 - 7.8.22 Electrooptical Materials with the Chalcopyrite Structure
 - 7.8.23 Rare Earth-Transition Metal Permanent Magnets (example: samarium cobalt and substituted samarium cobalt)
 - 7.8.24 Gadolinium Gallium Garnet (GGG) and Substituted GGG as a Substrate for Magnetic Oxide Films (see also Section 7.5)
 - 7.8.25 Materials for Magnetic Bubble Memories (Thin Magnetic Films Grown on Substrates)
 - 7.8.26 Germanium—High Purity Detector Grade
 - 7.8.27 3" or Greater Diameter Silicon Wafers
 - 7.8.28 Detector Grade Silicon Wafer with Resistivity 10,000–15,000 ohm-cm
 - 7.8.29 Indium Doped Extrinsic Silicon Crystals with Indium Concentration of about 10^{16}cm^{-3}
 - 7.8.30 Silicon on Sapphire (SOS)
 - 7.8.31 Pyrolytic Boron Nitride (PBN)
 - 7.8.32 Gallium Antimonide
 - 7.8.33 Indium Arsenide
 - 7.8.34 Indium Antimonide

8.0 INSTRUMENTATION TECHNOLOGY

- 8.1 Time-Domain Measurement Technology
 - 8.1.1 Oscilloscope Technology
 - 8.1.2 Time Interval Measuring Technology
- 8.2 Frequency-Domain Measurement Technology
 - 8.2.1 Radio Spectrum Analyzer Technology
 - 8.2.2 Panoramic and Digital Receiver Technology
 - 8.2.3 Real-Time Spectrum Analyzer Technology
 - 8.2.4 Frequency-Counter Technology
- 8.3 Frequency Standards and Signal Source Technology
 - 8.3.1 Frequency Standard Technology
 - 8.3.2 Frequency Synthesizer Technology
 - 8.3.3 Signal Generator Technology
- 8.4 Electrical Parameter and Digital Measuring Technology
 - 8.4.1 Network Analyzer Technology
 - 8.4.2 Digital Voltage Measuring Technology
 - 8.4.3 Microwave Power Meter Technology
 - 8.4.4 Active Signal Acquisition Probe Technology
- 8.5 Digital Instrument Technology
 - 8.5.1 Logic Analyzer Technology
 - 8.5.2 Microprocessor Development System Technology
 - 8.5.3 Analog-to-Digital and Digital-to-Analog Converter Technology
 - 8.5.4 Automatic Test Equipment Technology
 - 8.5.5 Digital Storage Oscilloscope and Digitizer Technology
- 8.6 Recording Technology
 - 8.6.1 Recorder/Reproducer Technology
- 8.7 Photographic and Optical Measurement Technology
 - 8.7.1 Photographic Interpretation Technology
 - 8.7.2 Laser Ranging Technology
 - 8.7.3 Laser Measurement Technology
 - 8.7.4 LIDAR/Laser Radar Technology
 - 8.7.5 Aerial and Streak Camera Technology
 - 8.7.6 High Speed Cinema Recording Camera Technology
 - 8.7.7 Microdensitometer Technology
- 9.0 TELECOMMUNICATIONS TECHNOLOGY
- 9.1 Telecommunications Systems Technology
 - 9.1.1 RF Communications Systems Technology
 - 9.1.2 Optical Communications Technology
 - 9.1.3 Acoustic Communications Systems Technology

9.1.4 Space Qualified Telecommunications Equipment Technology

9.2 Switching Technology

- 9.2.1 Circuit Switching Technology
- 9.2.2 Message Switching Technology
- 9.2.3 Packet Switching Technology

9.3 Modems and Multiplexing Technology

- 9.3.1 Modem Technology
- 9.3.2 Multiplexing Technology

10.0 COMMUNICATION, NAVIGATION, GUIDANCE, AND CONTROL TECHNOLOGY

10.1 Vehicle Control Technology

- 10.1.1 Spacecraft Guidance and Control Technology
 - 10.1.1.1 Spacecraft Stabilization Technology
 - 10.1.1.2 Spacecraft Attitude Control Technology
 - 10.1.1.3 Spacecraft Techniques for Space Environmental Effects
 - 10.1.1.4 Satellite Thermal Design Technology
 - 10.1.1.5 Onboard Sensor Techniques Providing Control Information
- 10.1.2 Air Vehicle Guidance and Control Technology
 - 10.1.2.1 Remote Control Techniques
- 10.1.3 Ship Guidance and Control Technology
 - 10.1.3.1 Navigation and Positioning Techniques
 - 10.1.3.2 Techniques for In-Water Speed Measurement and Integration
- 10.1.4 Submersible Guidance and Control Technology

10.2 Inertial Navigation Systems (INS) and Related Technology

- 10.2.1 Inertial Navigation Systems Integration Technology
- 10.2.2 Inertial Gimbaled Platform Technology
- 10.2.3 Inertial Strapdown Systems Technology
- 10.2.4 Floated Ball-Bearing Gyroscope Technology
- 10.2.5 Gas Bearing Gyroscope Technology
- 10.2.6 Flexure Rotor Gyroscope Technology
- 10.2.7 Ring Laser Gyroscope Technology
- 10.2.8 Electrostatically Supported Gyroscope Technology
- 10.2.9 Nuclear Magnetic Resonance Gyroscope Technology
- 10.2.10 Fiber Optics Gyroscope Technology
- 10.2.11 Low-Cost Gyroscope Technology
- 10.2.12 Accelerometer Technology
- 10.2.13 Autopilot Technology
- 10.2.14 Test Calibration and Alignment Technology

10.3 Cooperative Systems for Radio Navigation and Radio Communication Technology

- 10.3.1 Techniques for Platform Cooperative Radio-Navigation and Radio Direction Finding
 - 10.3.1.1 Radio Signal Conversion Technology
 - 10.3.1.2 Radio Signal Detection and Processing Technology
 - 10.3.1.3 Navigation Computation and Control Technology
 - 10.3.1.4 Systems Integration Technology
- 10.3.2 Platform Cooperative Radio Communication Technology
 - 10.3.2.1 Radio Signal-to-Noise Enhancement Technology
 - 10.3.2.2 Antenna Matching Over a Multiplicity of User Allocated RF Band Technology

- 10.3.2.3 Radio Signal Transmitting, Receiving Detection, and Processing Technology
- 10.3.3 General Avionics/Electronics Systems Technology
 - 10.3.3.1 Utilization of Solid-State Digital Components in System Design Technology
 - 10.3.3.2 System Architecture Technology
 - 10.3.3.3 Ruggedized/Hardened Equipment Technology
- 10.3.4 Display and Control Interface for Integrated Communication/Navigation Technology
 - 10.3.4.1 Improved HUD-Holographic Combiner Lens Technology
 - 10.3.4.2 Voice Control Input Technology

11.0 MICROWAVE TECHNOLOGY

11.1 Microwave Tube Technology

- 11.1.1 Electron Gun and Beam Design
- 11.1.2 Microwave Circuits
- 11.1.3 Microwave Tube Assembly

11.2 Microwave Solid-State Device Technology

- 11.3 High Power Microwave Control Component Technology
- 11.4 Waveguide and Component Technology

12.0 VEHICULAR TECHNOLOGY

12.1 Aeronautical Vehicle Technology

- 12.1.1 Laminar Flow Control (LFC)
- 12.1.2 Airfoil, Helicopter Rotor and Wing Designs (including high lift devices)
- 12.1.3 Computer-Aided Design and Manufacture (CAD/CAM)
- 12.1.4 Technologies for Integrating Sensor Subsystems
- 12.1.5 Control Configured Vehicles
- 12.1.6 Flight Control and Flight Management
- 12.1.7 Electromagnetic Hardening Technology
- 12.1.8 High Content Ratio, Durable, High Strength (HCR) Cores
- 12.1.9 High Survivability (Loss of Lubrication) Technology
- 12.1.10 Advanced Propellers
- 12.1.11 Advanced Structural Bonding

12.2 Marine Vehicle Technology

- 12.2.1 Hydrodynamic Design of Advanced Hull Forms
- 12.2.2 Hull and Pile Structure Design for Advanced Hydrofoils
- 12.2.3 Lightweight Marine Platform Structure Technology
- 12.2.4 Technology for Flexible Curtains and Skirts for Air Bubble Supported Platforms
- 12.2.5 Automated Platform Controls for Hydrofoils and Other High-Speed Marine Vehicles
- 12.2.6 Polymer Injection Technology for Drag Reduction

12.3 Deep Submergence Vehicle Technology

- 12.3.1 Manned Submersibles, Untethered
- 12.3.2 Manned Submersibles, Tethered and Diving Equipment
- 12.3.3 Unmanned, Tethered and Towed Submersibles
- 12.3.4 Unmanned, Untethered Vehicles
- 12.3.5 Syntactic Foam Technology

12.4 Gas Turbine Propulsion for Aeronautical Vehicle Technology

- 12.4.1 System Configuration, Aerodynamic and Thermodynamic Analysis
- 12.4.2 Variable Flowpath Technology
- 12.4.3 Centrifugal Flow Compressor Aerodynamics
- 12.4.4 Axial Flow Fan and Compressor Aerodynamics
- 12.4.5 Turbine Technology
- 12.4.6 Cooled Turbine Technology
- 12.4.7 Rotating Propulsion System Structures
- 12.4.8 High DN Rolling Element Bearings
- 12.4.9 Gas Film Bearing Design
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 - 14.7.6 Display Technology
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 - 16.5 Atmospheric Purification Technology
- 17.0 Nuclear Specific Technology
(Draft being finalized with the Department of Energy for later publication)

DEPARTMENT OF ENERGY

Defense Programs; List of Energy Related Militarily Critical Technologies

AGENCY: Department of Energy.

ACTION: Notice of publication of a list of energy related militarily critical technologies.

SUMMARY: The Export Administration Act of 1979 (PL 96-72) requires under Section 5(d) that an initial version of a list of militarily critical technologies be published in an appropriate form in the Federal Register not later than October 1, 1980. The Secretary of Defense has primary responsibility for developing this list of militarily critical technologies. In support of the

Department of Defense the Department of Energy has prepared a list of energy related militarily critical technologies. This list is attached.

DATES: Comments must be received on or before December 30, 1980.

ADDRESSES: Written comments should be directed to Julio L. Torres, Director, Office of International Security Affairs, Room 5F-C03, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585.

FOR FURTHER INFORMATION CONTACT: John A. Griffin, Director, Division of Politico-Military Security Affairs, Office of International Security Affairs, Room 5F-C56, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585 (202) 252-2127.

Leon Silverstrom, Assistant General Counsel for International Development and Defense Programs, Room 6F-055, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585 (202) 252-6975.

Dated at Washington, D.C. this 26th day of September, 1980.

Duane C. Sewell,
Assistant Secretary for Defense Programs.

DOE Critical Technology List

I. Introduction

This material was prepared in response to the Export Administration Act of 1979, which requires an interagency study, headed by the Department of Defense and with Department of Energy participation, of a proposed new approach to export control. The proposal suggests shifting the focus of control from end products to a set of critical technologies, in the hope that this shift of focus would provide a more effective system of controls and promote a broader range of exports without any increased risk to national security.

The attached list was developed in several iterations, with input from the National Laboratories and other selected DOE contractors. During this development a great deal of thought has been devoted to the problems of export control, and it is clear that substantially more work will have to be done to obtain a list that reflects all of the legitimate national security concerns, yet with enough specificity to be useful to export control officers.

Much of the background for the new approach to export control appears to have come from the so-called "Ducy" report.¹ The new approach suggested in the Ducy report is strongly based on the Export Administration Act of 1979,² wherein the Secretary of Defense is

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Part VI

Department of Energy

Defense Programs; List of Energy
Related Militarily Critical Technologies

DEPARTMENT OF ENERGY

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DATE: Comments must be received on or before December 30, 1980.

ADDRESSES: Written comments should be directed to Julio L. Torres, Director, Office of International Security Affairs, Room 5F-066, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585.

FOR FURTHER INFORMATION CONTACT: John A. Griffin, Director, Division of Politico-Military Security Affairs, Office of International Security Affairs, Room 5F-066, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585 (202) 252-2127.

Leon Silverstrom, Assistant General Counsel for International Development and Defense Programs, Room 6F-055, Forrestal Building, 1000 Independence Avenue, S.W., U.S. Department of Energy, Washington, D.C. 20585 (202) 252-6975.

Dated at Washington, D.C. this 28th day of September, 1980.

Deane C. Sewell,

Assistant Secretary for Defense Programs.

DOE Critical Technology List

I. Introduction

This material was prepared in response to the Export Administration Act of 1979, which requires an interagency study, headed by the Department of Defense and with Department of Energy participation, of a proposed new approach to export control. The proposal suggests shifting the focus of control from end products to a set of critical technologies, in the hope that this shift of focus would provide a

more effective system of controls and promote a broader range of exports without any increased risk to national security.

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Much of the background for the new approach to export control appears to have come from the so-called "Bucy" report.¹ The new approach suggested in the Bucy report is incorporated in the Export Administration Act of 1979,² wherein the Secretary of Defense is directed to bear primary responsibility for developing a list of militarily critical technologies and the Secretary of Commerce is directed to maintain the list as part of the commodity control list.

Following the Bucy report's recommendations, the Export Administration Act of 1979 notes that primary emphasis shall be given to:

- a. arrays of design and manufacturing know-how,
- b. keystone manufacturing, inspection, and test equipment, and
- c. goods accompanied by sophisticated operation, application, or maintenance know-how

that are not possessed by a country to which export is to be controlled and that, if exported, would permit a significant advance in a military system of the country.

It is essential in the development of a self-consistent list of critical technologies to devise practical definitions of the key terms, including "technology," "critical technology," and "keystone equipment." There are a number of definitions of these key terms devised and used by people seriously concerned about export control and technology transfer problems.³ Examining and testing these definitions helps to give us the essential ideas that must be embodied in practical ones suited for our use.

Many of the definitions of "technology" appear to be aimed at production items, and perhaps production engineering know-how, and therefore do not seem applicable to research and development technologies for advanced or undeveloped concepts. Thus, according to such definitions, the US does not have a "fusion technology," or a "beam weapon technology" because we do not have the know-how

to design let alone manufacture machinery or products to do those jobs. Yet, there are portions of the activities in these as well as other R&D programs that should be considered for export control.

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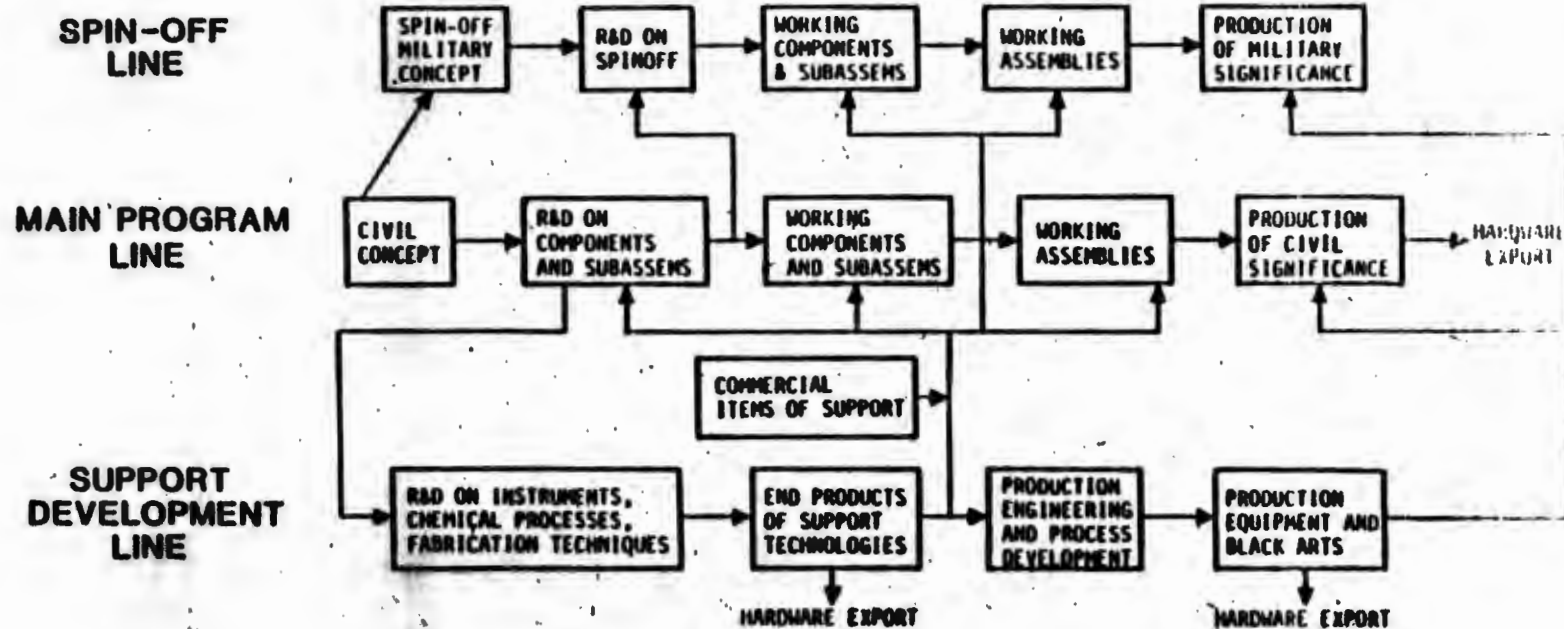


FIGURE 1

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A difficulty encountered in definitions of "critical technology" is that there is usually no time scale considered. Yet in deciding whether or not to license an export, a staff member must make some evaluation of the time it might take for the exported technology or hardware to appear as an adversary capability. In some cases the time may be so long that the capability would no longer be a threat. In other cases this may not be true. An ideal definition of critical technology would embody the condition that even after the time it takes for the adversary nation to absorb and apply the technology, it would still be considered critical. It seems especially important to keep in mind that some "high technology" R&D programs may require many years to yield a product, but the pay-off may be so great that it is wise to protect the relevant technology today. In the early stages of such a program, that is, before classification limits exchange, either side may benefit. Controlling exports or exchanges early in a development time scale therefore carries a risk.

In existing definitions of "keystone equipment" consideration of equipment required for advanced research and development activities is often overlooked. In such advanced studies, where problems of design are not yet solved, it is impossible to know what kind of equipment, materials, or components will be uniquely required for the manufacture of some final product. On the other hand, keystone equipment for the research and development phases can be identified.

In consideration of the difficulties of using definitions from other sources for selection of candidate hardware and ideas for export control, we propose the following ones for this study:

1. **Technology.** A specific technology is the body of knowledge acquired in the application of scientific principles to the solution of a specific technical problem.

Broader definitions of technology may be found, but are not appropriate in this report. Note that parts of the body of knowledge may be taken from other bodies of knowledge acquired previously, and parts may be acquired accidentally. The technical problem may be the construction of one magnetically confined fusion machine or the production of a large number of integrated circuits. It may also be an analysis of a new approach using existing hardware in a different way to solve the ABM problem. The quality of the end product depends upon the quality of the technology.

2. **Critical Technology.** A critical technology is a technology that would

provide an adversary with information detrimental to the security of the U.S.

Note that a decision regarding whether or not a technology is detrimental to the security of the United States may involve evaluating time scales as discussed earlier. Some technologies are not likely to result in hardware production for a number of years, but others in the hands of an adversary may produce an effect within a very short time. Note also that whether or not some form of the technology is available in other countries does not alter the characterization of the technology as "critical." It does affect the decision whether or not to export the technology. Furthermore, determining whether a US technology enjoys a competitive advantage is too subjective an evaluation to be a significant concern in this analysis. A US technology may appear attractive to an adversary because it reveals something about vulnerabilities in a related product used for military purposes, or because it indicates something of value about a related but reserved technology.

In these cases the competitive advantage of the product may be at best of only secondary importance. Finally, the fact that a technology has civil as well as military applications (dual-use) creates special concerns about the licensing of exports of the technology, but it has no bearing on whether the technology is "critical." It is only important to determine whether there can or will be a significant adverse impact on US security, whether it be military, economic, or political.

Figure 1 illustrates a way to summarize the kinds of equipment that are part of the reduction of a concept to practice. In the figure, a so-called "main program line" indicates an assumed project to produce some object for civil use. We have further assumed that there is a closely related concept for a military device that requires some of the same technology. The progress of the defense related concept toward production of a device proceeds along the "spin-off line." Supporting both programs or projects is the "support development line," which provides any kind of special hardware, equipment, process, etc. used in the programs for construction or instrumentation. This special hardware also requires some development work of its own. If there is to be production at the ends of the lines, there is a production engineering or process development activity that culminates in the means for production. Possibilities for exporting the technology that characterizes this effort occur at

any or all stages along the main program line and the support development line, but the spin-off line begins to be affected by classification at some point. Hardware can be exported also from the main and support effort as indicated in the figure. The earlier in the sequence of events the export takes place, the less important it would appear to be to require control. There are, of course, exceptions.

Keystone equipment can be identified at the R&D stages and at the production stage as special equipment, hardware, or processes developed to solve major problems in the respective stages. Considering that keystone items comprise more than just "equipment," we propose finally to change the description of these items to "keystone hardware," with the understanding that chemical or other processes are to be included.

3. **Keystone Hardware.** Keystone hardware is unique hardware components that are necessary for the effective development or application of a technology.

Keystone R&D hardware would include, for example, superconducting magnet wire and exploding bridge wire detonators. Examples of keystone production hardware would include unique manufacturing equipment, inspection and testing equipment, raw materials with special characteristics, and the chemical engineering equipment and materials needed for critical processes. The types of production problems solved include major improvements in rates of production and/or the quality of the product.

The list we have developed so far is a list of important technologies related to nuclear weapons research, development, and production that may be critical technologies. Certainly this list does not at this time constitute the set of technologies recommended for export control. Development of final lists, integrated with DoD efforts, will require substantial further effort.

II. DOE Critical Technologies List

A. Discussion

Table I is a list of technologies compiled from submissions by the DOE National Laboratories and appropriate DOE contractors. Accompanying the list of technologies are lists of hardware items associated with the technologies. Military and civil applications of the technologies and foreign availability information complete the table.

All of the technologies overlap or impact in some way upon the technology of nuclear weaponry. They are all therefore "critical" to some

degree. We believe that this list is best viewed as a starting point for more strict application of criteria important to controlling the export of US technology and hardware. In its present form, the table may be valuable in calling attention to areas of concern, but additional more detailed descriptive material is needed to help with decisions on real export cases.

Most entries in the "keystone hardware" column are themselves the end products of more primary technologies. There is, for example, a homopolar generator technology (H.B.), which has associated with it such keystone hardware as flywheels, bearings, brushes, magnetic coils, and others. It is not now clear to us how much to subdivide these technologies.

There are so many modern technologies that involve computer assistance in one way or another that we simply omitted reference to it except where it was particularly brought to our attention by someone in the business. A number of categories not so flagged in the table should have a "calculation technology" subheading and should have "computers" as keystone hardware.

In a collection of R&D technologies such as presented in Table I, the associated keystone hardware can seldom be classified as "associated end products," as the export act seems to call for. What we can list, however, are hardware items that are associated in some way with the technology. These items are either components of the main and spin-off development lines, or instrumentation of other support hardware that are crucial to the execution of these development lines. There is only an end product when the development program is successfully concluded. In a sense, then, the hardware items become more like indicators of the kind of work being carried out in the main program. Controlling the export of such equipment may force certain inconveniences or hardships on foreign scientists, even though the equipment itself is not directly of defense significance. It has been argued, however, that in the end, if foreign scientists are forced by export controls to invent their own support equipment, they will be more knowledgeable about the subjects than if they had been allowed to buy them.

In Table I, applications are sometimes listed for the entire main category, and if there are further applications for some of the keystone hardware items, they are listed additionally.

Finally, there are many "Black Arts" or tricks of the trade, which we cannot

list as keystone hardware, but which may be just as essential to the proper operation of some process or piece of equipment as the hardware itself. These arts or tricks usually work in the direction to protect our technologies, so it's probably well to leave them unpursued.

B. Critical Technologies Table

1. Index to Table

- I. Nuclear fuel cycle technology.
 - a. Uranium enrichment.
 1. Gaseous diffusion.
 - a. UF₆ transport and purification.
 - b. Diffuser technology.
 - c. Calculation technology.
 - d. Reserved.
 - e. Reserved.
 - f. Feed/withdrawal technologies.
 2. Gas centrifuge.
 - a. Rotor design technology.
 - b. Bearing design technology.
 - c. Suspension design technology.
 - d. Bellows mfg. technology.
 - e. Drive system mfg. technology.
 - f. Suspension system mfg. technology.
 - g. Reserved.
 - h. Reserved.
 - i. Reserved.
 - j. Reserved.
 - k. Reserved.
 - l. Flow system technology.
 - m. Auxiliary technologies.
 - n. Computer software technology.
 3. Laser isotope separation.
 - a. Computer modeling technology.
 - b. Laser technology.
 - c. UF₆ handling technology.
 - d. Molten U handling technology.
 - e. Ion extraction technology.
 - f. Atomic vapor source technology.
 - g. UF₆ spectroscopy.
 - h. Atomic U spectroscopy.
 - i. Switching technology.
 - j. Reserved.
 4. Plasma process.
 - a. Superconducting magnet technology.
 - b. U plasma technology.
 5. Calutron technology.
 - a. Magnet technology.
 - b. Source technology.
 6. Aerodynamic processes.
 - a. UF₆ flow technology.
 - b. Skinner technology.
 7. Chemical exchange.
 - a. Contactor technology.
 - b. Uranium compound handling technologies.
 - c. Recycle technology.
 - d. Materials handling technologies.
 - E. Reprocessing technology.
 8. Heavy water production technology.
 1. GS process technology.
 2. Vacuum distillation technology.
 3. D₂O analytical technology.
 - D. Fuel fabrication.
 1. Pellet fabrication technology.
 2. Cladding technology.
 3. Coated particle technology.
 - E. UF₆ production.
 1. Uranium oxide hydrofluorination technology.
 2. UF₆ fluorination technology.
 3. UF₆ purification technology.

4. HF mfg. technology.
5. Fluorine mfg. technology.
- F. Fusion reactors.
1. Pressure vessel technology.
2. Cooling cycle technology.
3. Control technology.
4. Maintenance technology.
5. Safety technology.
- G. Electro-nuclear breeders.
- H. Fusion technology.
- A. Very high power laser technology.
- B. Charged particle accelerator technology.
- C. Fusion pellet technology.
1. Pellet fabrication technology.
2. Computer software technology.
- D. Magnetic confinement technology.
1. Superconducting magnet technology.
2. Switching technology.
3. Plasma technology.
4. Materials technology.
- E. Imploding liner technology.
1. Computer software technology.
2. Switching technology.
3. Implosion system technology.
- F. Impact fusion technology.
1. Impactor technology.
2. Computer software technology.
- G. Diagnostics technology.
- III. Reactor production of nuclear materials.
- A. Tritium production technology.
- B. Tritium handling technology.
- C. Pu-239 production technology.
- D. Pu-239 fabrication technology.
- E. Pu-238 mfg. technology.
- F. Reserved.
- G. Reserved.
- IV. Nuclear weapons technology.
- A. Computer technology.
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2. Component mfg. technology.
3. Interactive graphics technology.
4. Operating systems technology.
- B. R&D technology.
1. Computer calculations.
- a. Language technologies.
- b. Code technologies.
2. Development testing technology.
3. Live nuclear test technology.
4. Component fabrication technology.
- C. Production technology.
- D. Special component technologies.
- E. Special materials technologies.
1. Fabrication technologies.
2. Purification technology.
3. Pyrotechnics fabrication technology.
4. Thermite composite fabrication technology.
5. Plasma polymerization technology.
6. Explosive recrystallization technology.
7. Large diameter high pressure storage vessel technology.
8. Paper honeycomb fabrication technology.
9. Silicone adhesive technology.
10. Nickel carbonyl [Ni(CO)₄] coating technology.
11. Thin film hydriding technology.
12. Electrical feedthrough technology.
- V. MHD.
- A. Superconducting magnet technology.
- B. Materials technology.
- C. Liquid metal handling technology.
- D. Plasma studies.
- VI. Advanced seismic detection.
- A. Seismometer technology.
- B. Signal processing technology.

C. De and command transmission and reception technology.
VII. Satellite technology.
A. Detector technology.
B. Data transmission and reception technology.

VII. Electronics.
A. Semiconductor mfg. technology.
IX. Safety, security, and survivability technology.
A. Reserved.

B. Encryption technology.
C. Electronically assisted physical security.
D. Weapons survivability.
E. Reserved.

DOE Critical Technologies

Critical technologies	Keynote hardware	Military applications	Civil applications	Foreign availability
I. Nuclear fast cycle technology				
A. Uranium enrichment		Nuclear weapons, nuclear propulsion, space power reactors, portable power reactors.	Power reactors, research reactors	
1. Gaseous diffusion				UK, France, USSR, FRG, Netherlands, PRC, Sweden, Switzerland.
a. UF ₆ transport and purification	UF ₆ -rated materials of construction. Compressors. Floating shaft seals (seal gas ballast).		Seals for reactive gas systems, e.g., fluorine.	France, UK, FRG, USSR, PRC.
	Valves for UF ₆ .	Valves for reactive gas systems.	Valves for reactive gas systems.	Widely available.
	Heat exchangers for UF ₆ .	Heat exchangers for e.g., fluorine.	Heat exchangers for e.g., fluorine.	France, UK, USSR, PRC.
	Cleaning solvents.			
b. Diffuser technology	Barrier material, Diffuser housings, Nickel powder. Porous nickel metal. Barrier manufacturing equipment.	Battery plates, glass, alloys.	Battery plates, glass, alloys.	UK, Canada.
c. Computer software technology	Computers	Many uses.	Many uses.	UK, France.
d. Reserved				
e. Reserved				
f. Feed/withdrawal technologies				
2. Gas centrifuge				USSR, UK, Netherlands, FRG, Japan, France, Pakistan, Australia, Italy, Switzerland, Sweden, Brazil.
a. Rotor design technology	Rotors			
b. Bearing design technology	Bearings			
c. Suspension design technology	Suspension systems			
d. Bellows mfg. technology	Bellows forming die and mandrels. Hydraulic forming equipment (isostatic process). Machining steel.	Many uses.	Many uses.	UK, France, Japan, others.
e. Drive system mfg. technology	Synchronous motors (800-2000 Hz) High frequency steel.		Tumble mills, high speed grinding.	Widely available.
f. Suspension system mfg. technology	Magnets (metallic or ceramic dampers).		Load speaker magnets.	Widely available.
g. Reserved				
h. Reserved				
i. Reserved				
j. Reserved				
k. Reserved				
l. Flow system technologies	Valves, bellows sealed, nickel, metal or nickel plated. Pressure transducers for UF ₆ . Al alloy piping. Process computers. Vacuum systems, Vacuum pumps. Purge systems. Balancing equipment. Leak detectors. Mass spectrometers. Inverters, converters, frequency changers and generators, 3-phase 600-2000 Hz. Electrical power supplies.		Chemical processing industry. Chemical processing industry.	UK, Switzerland, FRG, France. FRG. France, FRG. FRG, others. USSR, UK, Netherlands, FRG. FRG. UK, FRG. UK, FRG. UK, FRG, Japan. UK, FRG.
m. Auxiliary technologies				
n. Computer software technology	Computers	Separation of fission isotopes.	Purifying materials, processing reactor wastes.	Canada, France, FRG, Japan, S. Africa, UK, USSR.
3. Laser isotope separation		Laser guided weapons.	Chemical analysis, photochemistry.	USSR, France, Israel, FRG, Japan, others.
a. Computer modeling technology	Computers			
b. Laser technology	Tunable diode lasers and amplifiers. Tunable IR & UV lasers and amplifiers. Tetrodes (> 1 MW). High efficiency high rep. rate copper lasers and amplifiers. Electro-optical components. Excimer lasers and amplifiers. Tunable dye lasers and amplifiers.			USSR, France, Israel, FRG, Japan, others.

DOE Critical Technologies—Continued

Critical technologies	Key-state hardware	Primary applications	End applications	Foreign availability
c. UF, handling technology	Very high power dye lasers. Equipment for growing dode crystals.			USSR, France, FRG, UK, Netherlands, Israel, Japan, S. Africa, Brazil.
d. Molten U handling technology	Supersonic nozzles UF, compatible materials of construction.			
e. Ion extraction technology	Crucibles			
f. Atomic vapor source technology	Electron beam heated vapor sources (high power strip sources).			
g. UF, spectroscopy	Tunable diode laser UV spectroscopy.			
h. Atomic U spectroscopy	Tunable dye lasers			
i. Switching technology (~ 1000 pps, high current)	Power supplies Thyristors Spark gaps Low inductance capacitors			
j. reserved				
4. Plasma process & Supercond. magnet technology	Supercond. magnets Magnet wire Cable Cryogen handling equipment Winding and joining equipment. Magnets for large volume, uniform fields. Plasma forming equipment	MHD generators, magnets for advanced (ASV), supercond. propulsion systems.	MHD generators, Maglev transport, magnets are prospecting.	Japan, UK, FRG, France, USSR, Italy.
b. U plasma technology Materials of construction.				
5. Cesium technology				
a. Magnet technology Magnets for large uniform fields	Regulated high voltage supplies			
b. Source technology				
6. Aerodynamic processes				
a. UF, flow technology	Compressors for UF, UF-related materials of construction. Rotating shaft seals Heat exchangers			FRG, S. Africa, Brazil, Sweden, France, UK, USSR, FRG, PRC.
b. Steamer technology				
7. Chemical exchange				
a. Contactor technology	Contactors with low stage residence times (~ 20 st). Centrifugal liquid-liquid contactors. Pulse column liquid-liquid contactors. Other multistage liquid-liquid contactors.	Platinum and Ruten product separation.	Chemical process industries, waste treatment, many others.	France, Sweden, FRG, UK, Japan, many others.
b. Uranium compound handling technologies				
	Materials of construction. Fluoroplastics or fluoroplastic-lined pipe, valves, pumps, other equipment. Specialized uranium extractants	Fast reprocessing-Pu recovery	Power reactor cycle, plastics, chlorinated, Chemical analysis.	Many industrialized countries.
	Electrolytic diaphragm materials.			
c. Recycle technology	Ion-exchange resins (pellicular). Cells for reduction by electrolysis (especially mercury-cathode diaphragm cells). Specialized multiple effect evaporators. Reverser cascade systems which withstand high acid concentrations.		Chloralkali industry.	Many industrialized countries.
d. Materials handling technologies	See designated (*) items under "Reprocessing Technology".			
Reprocessing technology		Nuclear material production	Power reactor fuel cycle	Belgium, France, FRG, India, Italy, Japan, Taiwan, UK, USSR.
	Pool shears			

DCE Critical Technologies—Continued

Critical Technologies	Key items hardware	Military applications	Civil applications	Foreign industry
	*Chemical reactors			
	*Chemical contactors			
	*Mixers			
	*Pulse columns			
	Dissolution equipment			
	Tributyl phosphate			
	*HSPA filters			
	*Ion exchange materials which will withstand intense radiation			
	*Oil-gas treatment systems			
	Manipulators for hot cells			
	Shielding windows for hot cells			
	*Process control instrumentation			
	Radiation monitoring instrumentation modified for fuel reprocessing			
	*Computers			
C. Heavy water production			Power reactors	Canada, France, USSR (7), Norway (7), India, Argentina
1. OS process technology	Packed tower contactors		Chemical industry	Canada, India
	Gas blowers for H ₂ O/Water pumps		Water purification	
	Heat exchangers			
	Condensers			
	Piping			
	Valves			
	Tanks			
	Storage vessels			
	Gas compressors			
	Process instrumentation			
	Water treatment equipment			
	Steam generating equipment			
2. Vacuum distillation technology			Chemical industry	
	Towers			
	Steam ejectors			
	Vacuum pumps			
	Water pumps		Water purification	
	Condensers			
	Condensers			
	In process storage tanks			
3. D.O. analytical technology				
	Single beam infrared spectrophotometry			
D. Fuel fabrication		Nuclear propulsion, nuclear materials production	Power reactor fuel	France, USSR, Canada, FRG
1. Pellet fabrication technology	Pellet presses			
	Grinding furnaces			
	Grinding and grading equipment			
	Inspection equipment			
	Assay equipment			
2. Cladding technology				France, USSR, Canada, FRG
	Welding equipment			
	Inspection equipment			
	Leak detection equipment			
	Tubing mfg. equipment			
	H ₂ -free aluminum			
	Zirconium casting vacuum furnaces			
3. Coated particle technology	Spherical particle fabrication equipment Particle coating equipment			
	Presses			
	Slurry materials			
	Furnaces			
E. UF ₆ Production		Feed for enrichment plant	Feed for enrichment plant	USSR, France, FRG, Belgium, UK, Japan, FRG, S. Africa, Italy, Canada
1. Uranium oxide hydrofluorination technology (to produce UF ₆)	Screw reactors		Chemical industry	
	Stirred fluid-bed reactors		Chemical industry	
	Fluid-bed reactors		Chemical industry	
	Insulated pipes		Chemical industry	UK, Canada
	Flame towers		Chemical industry	Canada
2. UF ₆ fluorination technology (to produce UF ₆)				
	Fluid beds		Chemical industry	
	Insulated pipes		Chemical industry	UK, Canada
3. UF ₆ purification technology	Distillation columns			France
	Absorption traps			
	Nickel-plated steel pipe			
	Bottoms-coated valves			UK, France, Switzerland
4. HF manufacturing technology	Calcium fluoride		Chemical industry	
	Sulfuric acid	Chemical industry		

DOE Critical Technologies—Continued

Technology	Materials & Chemicals	Primary and Secondary	End Applications	Foreign Availability
4. Fluorine mg. technology	Fluorine cells High energy carbon anodes Hydrofluoric acid (HF) Potassium fluoride Chlorine trifluoride	Reactor fuel	Fluorocarbon monomers	UK, France
F. Fission reactors		Propulsion, electric power	Electric power, process heat	Canada, USSR, FRG, France, Japan, UK, Belgium
1. Pressure vessel technology	Very large casting and welding equipment Inspection equipment (e.g., radiography, etc.)			
2. Cooling cycle technology	Very large forging machinery Pumps Heat exchangers Pressure, temperature, flow instrumentation Clean-up systems Valves			
3. Control technology	Heavy water Computers Control rod drives Monitoring instrumentation Emergency systems			
4. Maintenance technology	Fuel element handling equipment Inspection equipment Computers Monitoring equipment SCRM equipment Inspection equipment and procedures			
6. Electro-nuclear breeder	High current acceleration Targets Ion sources Beamline equipment		Electric power production	
8. Fusion technology		Nuclear fuel production, neutron beams, RF systems, effects simulation Laser weapons, effects simulation	Electric power production	Canada, France, FRG, Italy, Japan, Poland, UK, USSR
A. Very high power laser technology	Very high power lasers Very high power amplifiers Mechanical and electro-optical hardware High voltage systems (pulse power) High current high rep. rate switches with low jitter Pulsing systems Single point diamond cutting tools Diamond tools Optical coating equipment Optical polishing equipment for large optical elements Other strength protection equipment Gas handling equipment MgF ₂ windows Glass components Flash lamps Electron beam pumping equipment Other pumping equipment		Welding	
B. Charged particle accelerator technology	Linear induction accelerators Beamlines Heavy ion accelerator modules High energy density capacitors Superconducting magnets Heteropole generators High rep. rate high current switches with low jitter Large thermionic cathodes Pulsed alternators Pulsing systems Computers Ion sources Electron sources Vacuum system equipment	Particle beam weapons, weapon physics simulation, neutron sources	Physics research, medical research, x- ray machines	USSR, France, FRG, others
C. Fusion pellet technology				
1. Pellet fabrication technology	Pellets Pellet manufacturing equipment			

DOE Critical Technologies—Continued

Critical technologies	Vacuum hardware	Utility applications	Gen applications	Foreign availability
	Pellet loading equipment (D ₂ gas handling, etc.).			
	Tritium handling equipment.			
	Pellet sorting and inspection equipment.			
	Pellet manipulation equipment.			
2. Computer software technology	Computers			
3. Magnetic confinement technology		MHD propulsion, MHD power, explosive MHD.	MAGLEV—transportation	Explosive
1. Superconducting magnet technology	See I.A.A.s.			Japan, FRG, UK, USSR, European community.
2. Switching technology	Power supplies			
	Energy storage components			
	Thyristors			
	Spark gaps			
3. Plasma technology	Low inductance capacitors			
	Power supplies			
	Capacitors			
	Switches			
	Quenchers			
	Neutral beam injectors			
	Plasma clean-up equipment			
	Purifying systems			
4. Materials technology	First wall materials			
	Other materials of construction.			
E. Igniting liner technology			Electric power production	Poland, USSR.
1. Computer software technology	Computers			
2. Switching technology	See I.A.A.s.			
3. Ignition system technology	Magnets	Nuclear and non-nuclear weapons.		
	Lasers			
	High explosives			
	Lasers			
	Plasma guns			
	Other plasma preparation equipment.			
F. Impact fusion technology				USSR, France.
1. Impactor technology	Multi-stage gas guns			
	Specialty developed projectiles.			
	Electromagnetic guns			
	High energy density capacitors.			
	Switching equipment			
	Rotating flywheel energy storage systems.			
	Propellants			
	Targets			
2. Computer software technology	Computers			
3. Diagnostics technology	Shock sensors	Nuclear weapon development		
	Neutron detectors			
	Gamma detectors			
	X-ray detectors			
	Fast timing circuitry			
	Fast oscilloscopes (picosecond sweep).			
	Computers			
	X-ray transmission equipment			
	Neutron radiography equipment			
	Microwave atomic microscopy equipment			
	Spectrometry equipment			
	Magnetic field measuring equipment			
	Thomson scattering equipment			
	Interferometry equipment			
	Pi probes			
	Flash X-ray equipment			
	Diagnostic lasers			
H. Reactor production of nuclear materials				
A. Tritium production technology		Nuclear weapons	Fusion reactors, self sustaining components, tokamaks, pinches, D-T neutron sources.	France, FRG, UK, USSR.
	Reactors			
	Lithium alloys			
	Distillation equipment			
	Lithium target fabrication equipment.			
	Tritium recovery equipment			
	Calutron			
B. Tritium handling technology		Nuclear weapons		France, FRG, UK, USSR, Hungary, Netherlands, Poland.
	Pumps			
	Valves			
	Piping			
	Mass spectrometers			
	Absorption beds			
	Glasses with special diffusion properties.			
	Measuring instruments			
C. Pu-239 production technology		Nuclear weapons	Breeder reactors for electric power production.	UK, France, USSR, FRG, India.
	Reactors			
	Target fabrication equipment			

DOE Critical Technologies—Continued

Critical technologies	Category	Technology	Out-applications	Current availability
D. Pu-238 fabrication technology	Nuclear weapons	Fuel elements		
		Solvent extraction equipment		
		Distillation equipment		
		Ion exchange materials and equipment		
		Oil-gas treatment systems		
		Glove boxes		
		Analytical chemistry equipment		
E. Pu-238 manufacturing technology	Nuclear weapons	Equipment for reduction to metal		
		Casting furnaces		
		Graphite molds		
		Glove boxes		
		Metallurgical equipment		
		Metal forming machinery		
		Equipment for production of oxides, nitrides, carbides of Pu		
		Pellet presses		
		Analytical equipment		
		Stripping furnaces		
F. Reserved	Nuclear weapons	X-ray machines		
		Metallographs equipment		
		Other measuring equipment		
G. Reserved	Nuclear weapons	Reactors		
		Sp-237		
		Fuel element, distillation, separation, precipitation and reduction equipment		
H. Nuclear weapons technology	Nuclear weapons	High performance, high capacity computers		
		Cooling systems		
		High performance, high capacity peripheral memories (discs, tapes)		
		Magnetic bubble memories (See VELA)		
		Interactive terminals		
		Interactive terminals, Other I/O		
		Computers, Terminals, Printers		
I. Computer technology	Nuclear weapons	Pin technique equipment		
		High speed framing cameras		
		High speed streak cameras		
		Flash x-ray machines		
		Image intensifiers		
		Microdensitometers		
		High explosive firing equipment		
		Firing site		
		Particle accelerators		
		Computers for data reduction		
J. Development testing technology	Nuclear weapons	High speed oscilloscopes		
		High speed digitizers		
		High speed counters		
		High quality large diam. coax cables		
		Fiber optics cables and components		
		Photomultiplier tubes		
		Time domain reflectometers		
		High speed calibration and data recording equipment		
		Radiochemistry equipment		
		Large-hole drilling equipment		
K. Live nuclear test technology	Nuclear weapons	Computerized network analyzers		
		Microdensitometers		
		Image enhancement equipment		
L. Component fabrication technology	Nuclear weapons	UF ₆ to metal conversion equipment		
		PuO ₂ to metal conversion equipment		
		Uranium casting equipment		
		Uranium machining equipment		
		Depleted or natural U components		

DOE Critical Technologies—Continued

Critical technologies	Air force hardware	Military applications	Civil applications	Foreign availability
	Enriched U components			
	Plutonium casting equipment			
	Plutonium machining equipment			
	High explosives casting equipment	High explosive shells, bombs, etc.		
	High explosives pressing equipment	High explosive shells, bombs, etc.		
	High explosives finishing equipment			
	Electrochemical machining equipment	Aircraft	Aircraft	
	Explosive forming facilities			
	Sheet forming equipment			
	Isostatic and hydrostatic presses	Conventional munitions	Aircraft engine parts	
	Electron beam welding equipment	Many aircraft parts	Pipelines, medical units, aircraft	
	Laser welding equipment	Many		
	Planar winding machines	Many		
	High-precision 2-5 axis NC machine tools	Aircraft parts, rocket motors, rotary vehicles	Tool & die mfg., aerospace, aircraft parts	Japan, FRG, France, Italy, UK, Switzerland, Belgium
	Dimensional-inspection machines (contact, non-contact, laser)	Many	Many	
	Frequency synthesizers	Radar, communications and ECM equipment		
	Spectrum analyzers	Radar, communications and ECM equipment		
	Laser holography equipment			
	X-ray holography equipment			
	X-radiography equipment			
	Laser interferometry equipment			
	Laser lead back systems	Missile	Laser fusion technology	France
	Rotary and linear feedstock systems	Aircraft, naval, aerospace parts	Tool & die units, engine parts	Switzerland, FRG, Japan
	High-precision spindles (air bearings and vibration isolation)	Missile	Laser fusion, other optics	Japan
	High precision linear induction motors	Missile	Laser fusion, other optics	Netherlands
	High precision lead screws	Missile	Laser fusion, other optics	UK
	Single point diamond anodes	Missile	Laser fusion, other optics	FRG, Netherlands (7), S. Africa (7), Israel (7), USSR (7)
	Mathematically controlled systems hardware	Many	Auto, machinery, aircraft production	
	Advanced NC systems			
	Leak detection equipment for 10^{-14} cc/s	Neutron generator tubes	Nuclear reactors	Japan
	Electron microscopes		Harmonic seals, IC mfg., electron tubes	France
C. Production technology	See A/B/C			
D. Special component technologies	High voltage power sources (battery divert)	Space launch & missile testing	Accelerators	
	Exploding leadwire detonators		Blasting	
	Cold cathode switches (cryotrons, apytrons)			
	Neutron storage		Oil well logging, uranium logging, neutron standards, neutron radiography, neutron medicine	The Netherlands, USSR
E. Special materials technologies 1. Fabrication technologies	High energy density capacitors			
	Fluoropolymer materials	Reentry vehicles, aerospace components	Space vehicles, aerospace components	Japan, France
	Composite materials	Aerospace components, structures	Aerospace components, structures, gas & liquid storage	France
	Semiconductors	Naval reactor propulsion systems	Reactor controls	USSR
	Synthetic	Guidance systems, optical systems, structures	Electronics components, x-ray windows, space systems	France, USSR, UK
2. Purification technology	Synthetic stainless steel alloys			
	Ultrahigh purity rare earths (Sc & Y)			
3. Pyrotechnics fabrication technology	Metal hydride synthesis facilities	Ordinance weapons, missiles	Flarepots, valve actuators, gas	Many countries
4. Thermite composite fabrication technology	Special composition dies	Deterrent containers	Propulsion	
		Ordinance weapons, deterrent containers	Welding, deterrent containers	Many countries
5. Plasma polymerization technology (thin films)	Plasma coaters and etchers	Ordinance weapons	Protective coatings for corrosion prevention	
6. Explosive recrystallization technology		Ordinance weapons	Commercial explosives, explosive devices	
7. Large diameter, high pressure storage vessel technology				
8. Paper honeycomb fabrication technology	Hobe machine	Aircraft, missiles	Aircraft	

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DOE Critical Technologies—Continued

Critical technologies	Keyline hardware	Utility applications	Gov. applications	Foreign availability
2. Encryption technology	Microprocessors			
C. Electronically assisted physical security	Sensors	Weapon storage site protection	Power plant protection	
	Microprocessors			
	Signal processing equipment			
D. Weapon survivability	Sensors			
	Microprocessors			
X. Reserved				

C. Technology Descriptions

I. Nuclear Fuel Cycle Technology

A. Uranium Enrichment. The only naturally occurring fissile material suitable for use in nuclear weapons is uranium-235 (^{235}U). It makes up approximately 0.71% of natural uranium. Some nuclear reactors contain only natural uranium fuel. Others require enriched fuel, that is, the fuel must be made of uranium that has been processed so that the ^{235}U concentration is higher than 0.71%. For use as fissile material in nuclear weapons, uranium must be highly enriched. The gaseous diffusion method of enrichment, which depends on the fact that the rate of diffusion of a gas is inversely proportional to the square root of its molecular weight, has been the method used. It requires a large plant with many (several thousand) diffusion stages, and has high power requirements. Some of the newer technologies developed or under development offer possible cost advantages for large scale production, and may be more adaptable to smaller scale use.

B. Reprocessing Technology. Reprocessing is required for optimal use of reactor fuel, whether the goal is plutonium production for weapons, or production of power. Plutonium-239 (^{239}Pu) is a suitable fissile material for weapons and for reactor fuel. When ^{235}U is exposed to thermal neutrons, as in a reactor, ^{235}U is formed by neutron capture, and decays by beta emission to ^{239}Np , then to ^{239}Pu . For recovery of the ^{239}Pu thus formed in reactor fuel elements, reprocessing is required. Various other isotopes of Pu also are formed, some of which are undesirable for use in weapons. Suitable fuel management and refueling timing can minimize their formation and obviate the need for Pu isotope separation, as well as reduce the safety hazards during reprocessing.

Uranium-233, which is also fissile and does not occur in nature, can be produced by neutron capture by thorium-232. Its recovery also requires reprocessing.

C. Heavy Water Production. Heavy water (also known as deuterium oxide,

D_2O) occurs in nature. Using ocean water as a reference, the atomic abundance of deuterium in natural hydrogen is 0.0149%.

Three methods for separating D_2O from light water have been known for many years. Electrolysis of water and distillation both preferentially concentrate D_2O in the residue. Similarly, in the reaction $\text{H}_2\text{O} + \text{D}_2\text{O} \rightleftharpoons \text{D}_2 + \text{H}_2\text{O}$, the reverse reaction predominates, and at equilibrium the ratio of ^2H to ^1H in the liquid phase (i.e., D_2O to H_2O) is about three times as great as in the phase (that is D_2 to H_2).

Heavy water is of interest to the weapons community because it is a source of deuterium for the D-T reaction of thermonuclear weapons, and because of the fuel usage and conversion characteristics of heavy water moderated nuclear reactors. Heavy water moderated reactors, such as Canada's CANDU reactors, can be fueled with natural uranium, and have fairly high conversion ratios of ^{235}U to ^{239}Pu because of deuterium's very low neutron capture cross section. They therefore allow the possibility of production of weapons-grade fissile material without need for access to uranium enrichment. This is also possible using graphite as a moderator, but it is not possible using ordinary water.

D. Fuel Fabrication. Fabrication of reactor fuel elements is a necessary link in the chain of processes leading from raw uranium ore to the use of reactors for power or the production of weapons grade plutonium. Dependence on an outside supplier of fuel elements may make it difficult or impossible for the possessor of a reactor to manage refueling timing to optimize ^{239}Pu production. Technology used in the fabrication of some types of fuel elements may also be applicable to the fabrication of weapons components. For example, glove box lines, alpha-counters, machine tools, and other equipment would be the same, or similar.

E. UF_6 Production. Uranium hexafluoride (UF_6) is the most volatile uranium compound known. At room temperature it is a dense white solid

with a vapor pressure of 120 mm, but it can be readily sublimed or distilled. The gaseous diffusion enrichment process, as well as other enrichment processes such as the gas centrifuge use UF_6 . See section I. A. for discussion of enrichment.

F. Fission Reactors. Many aspects of fission reactor technology are useful in providing a technology base for nuclear weapons development. For example, computer codes for calculating the progress of reactor excursions may be applicable to analysis of weapon neutronics. Reactors also provide the ability, to varying degrees, to breed or form ^{239}Pu from ^{238}U , and tritium from ^6Li , for use in weapons. Experience with nuclear instrumentation and familiarity in dealing with radiation problems are also helpful in a weapon program. Criticality experiments for weapon design studies resemble some of the aspects of reactor operation. Operation of research reactors would be especially good experience.

G. Electro-nuclear Breeders. Electro-nuclear breeder technology, to breed ^{239}Pu or ^{235}U with the aid of fission sustained with the assistance of neutrons generated from a target bombarded by high energy particles, is of interest for two reasons. The fissile material that is bred can be used in weapons, and the charged particle source and accelerator technologies developed can be applied in other critical areas.

II. Fusion Technology

A. Laser Technology. Laser technology has many possible critical applications, ranging from isotope enrichment to laser guided weapons to laser weapons. Supporting technologies for high voltage systems also have multiple applications. Energy storage and switching equipment is common to most directed energy systems.

B. Charged Particle Accelerator Technology. This technology is necessary in some approaches to inertial confinement fusion, in directed energy weapons studies, fusion reactor materials development, and to some extent in magnetic confinement fusion and basic physics research. The relevance of accelerator technology to

national defense makes it a critical technology in a military sense, but it is also critical politically and possibly economically as well. Research and development in this area is well advanced in the USSR, and there has tended to be rather unrestricted exchange between the USSR and the US concerning new component design concepts. At the same time, no one is sure that exchanged information has included the most highly developed refinements.

C. Fusion Pellet Technology. Aspects of fusion pellet technology may have direct applicability to fusion weapons.

D. Magnetic Confinement Technology. Plasma studies of MHD stability in magnetic confinement could support understanding of weapons hydrodynamics. Also deuterium and tritium reaction rate studies as well as the technology of handling these materials would be transferable to weapon programs.

E. Imploding Liner Technology. Implosion technology has been fundamental to nuclear weapon development since the days of Fat Man. Modern calculation technology, detonation systems, and experimental diagnostics all still have application to weapons.

F. Impact Fusion. To achieve impact fusion, a massive (by controlled inertial fusion standards) target of a few milligrams of deuterium and/or tritium is accelerated to velocities of the order of 10^6 m/s. A difficult part of the technology is achieving sufficiently high speeds to bring the material together forcefully enough to cause fusion.

G. Diagnostics Technology. Diagnostics instruments for controlled fusion, with requirements to function under conditions of high temperature, in a radiation environment, or with very short time response characteristics, are also important in nuclear weapons testing. Some fusion diagnostic equipment is useful also in nuclear weapon R&D programs for diagnosing the hydrodynamic performance of device mockups.

III. Reactor Production of Nuclear Materials

A. Tritium Production Technology. Tritium (T) is produced in nature by the action of cosmic radiation on nitrogen in the upper atmosphere. It is also produced as an unwanted contaminant in the water coolant of reactors, and may be produced through neutron bombardment of lithium-6 by the reaction



It is of interest because of its use as a fuel in thermonuclear weapons. Deuterium (D) is naturally occurring, and fusion may be made to occur between two deuterium nuclei. However, the peak reaction rate coefficient of the D-D reaction is considerably less than that of the D-T reaction.

B. Tritium Handling Technology. Tritium is a beta emitter. Being an isotope of hydrogen, it can enter into all the chemical reactions of hydrogen, including those in the body. Gaseous tritium is not significantly absorbed into the body, but water containing tritium is. It can be taken up through the lungs or mouth or absorbed through intact skin and is dispersed through all the body fluids, though exchange with the hydrogen in other body tissues is slow. In addition to its radioactive health hazard aspects, tritium has all the handling difficulties of ordinary hydrogen, with higher safety and cost penalties for failure. Experience in the handling of the material would be valuable in a weapon program.

C. Plutonium-239 Production Technology. Plutonium does not occur in nature except in very minute quantities. Several isotopes are known. Plutonium-239 is produced by neutron absorption by ${}^{238}\text{U}$ and subsequent beta decay. It is a fissile material that can be separated chemically from uranium, an easier process than the isotope enrichment techniques needed to produce highly enriched uranium. Plutonium can also be used as a reactor fuel. A weapon made of plutonium can be smaller in size than a comparable weapon made of uranium. Contamination of ${}^{239}\text{Pu}$ with other Pu isotopes can make it less desirable for weapons and increase the hazards of handling it.

D. Plutonium-239 Fabrication Technology. Nuclear weapons components must be fabricated with good precision. Plutonium is a difficult and hazardous material to handle. It is toxic and an alpha emitting carcinogen. Plutonium is very complex, metallurgically. Working with ${}^{239}\text{Pu}$, as with any fissile material, requires that caution be exercised to avoid forming a critical mass when it is unintended.

E. Plutonium-239 Manufacturing Technology. Pu-239 is an alpha emitter with a half-life of 86 years. It is useful in radioisotope-powered thermoelectric generators and has been used for such applications as powering seismic and other experimental instruments on the lunar surface for Apollo missions. Unique handling difficulties arise from the fact that alpha decay keeps it at a relatively high temperature. Some of the processing and handling equipment for

Pu-239 is the same as for weapon grade plutonium.

F. Reserved.

G. Reserved.

IV. Nuclear Weapons Technology

A. Computer Technology. A very important element in a modern nuclear weapon R&D program is the correlation of experimental data with self-consistent theoretical models. Computers provide a convenient and effective way to carry out such correlations and to predict improvements within the limitations of the models. Modern computer manufacturing technology comprises not only the manufacturing technology of highly integrated solid state circuits, but also includes the general architecture of the system, that is, its logic flow, peripherals, operating system, and other overall characteristics. A very crucial element is the cooling system design.

Computers are very powerful tools in many areas of research as well as in development and production of all kinds of hardware of military interest. Large scale production and use of computers at least has the potential of affecting the economics of production management in many areas. Many U.S. companies have a competitive edge because of the wide use computer controlled processing.

Computer manufacturing technology is thus considered critical because of the wide applicability of such machines throughout all levels of industry. Loss of the U.S. advantage in computer availability could be detrimental to the security of this country.

B. R&D Technology. Nuclear weapon research and development methodology has developed in the U.S. over thirty-five years to a rather sophisticated state. The methodology is optimized to "fine-tune" weapon designs, guarantee reliability, explore the limits of design, and reveal new phenomena that can affect the next generation of weapons. The U.S. nuclear weapon R&D technology as a whole may not mesh well with the aims and intentions of another country, but knowledge of it and access to the associated hardware would be a boon to a new program if only to save the time and effort consumed in reinventing ways to acquire data, and assessing which are the important pieces of data to be gathered in the program. It is worth a great deal to know which particular ways to fabricate workable components, which ways to carry out critical tests, and which methods to gather data actually work best. We would estimate that years could be saved in an R&D effort if these technologies and hardware were widely available.

C. Production Technology. Nuclear weapon "production" is not production in the usual American sense of the word. There are very few processes in the final manufacturing that were developed especially for the production phase. Materials certification, fabrication techniques and inspection are for the most part the same as those used in the R&D portions of the programs. Final assembly and packaging are additional large scale activities that characterize nuclear weapon production, but aside from these, production technologies are substantially the same as R and D component fabrication processes. There are advantages to doing things this way. Processes are developed at no cost to the production program, and development testing is done on components that are going to look very much like the final production items. For production of a limited number of complex objects, the system is optimum.

Some portions of the fabrication technologies are critical because of the unusual requirements of working with nuclear materials. Making good parts of these materials is a non-trivial undertaking. In other cases there are "Black Arts" developed which give good yields, or special materials must be used to avoid compromising the performance of the end device. These technologies are critical because knowledge of them can result in a better product, a higher yield of acceptable parts, a less expensive process, or a more timely appearance of a new design.

D. Special Component Technologies. This category of technologies is critical because in general the technologies have been expensive and time consuming to acquire, and result in end products that are crucial to the reliable and proper functioning of a nuclear weapon. The problems solved by these technologies may be solved in other ways, but generally speaking the US technology is advantageous in the context of the US ground rules. Knowledge of these technologies could give relief from design constraints in developing programs, and allow advantages in time, system architecture, and support facility complexity.

E. Special Materials Technologies. These are some of the technologies that are supportive of the component fabrication technologies described earlier. Each requires development time, each provides some kind of advantage to the system design engineer, and each results in an overall advantage to the end product. The final improvement in a complex and highly optimized assembly may be large even though an improved

component manufacturing technique may seem relatively minor. These supporting technologies are critical in the sense that they make available to an adversary some of the design edge that a seasoned manufacturing array possesses.

V. MHD

When a thermally ionized gas or a conducting liquid is forced at high temperature, pressure and velocity through a duct situated in a transverse magnetic field, an induced voltage appears in the third mutually perpendicular direction, and this voltage may be tapped by electrodes within the duct. The heat required may come from combustion, nuclear power or solar energy. Magnetohydrodynamics (MHD) has the long range potential, when combined with a bottoming cycle, for producing electricity from coal combustion with an efficiency of about 80%. MHD can provide a portable system for conversion of chemical to electrical energy with high efficiency.

A. Superconducting Magnet Technology. Superconducting magnets are used in magnetohydrodynamics applications to achieve intense fields with low loss. Superconducting magnet technology is also of use in several other areas of interest.

B. Materials Technology. MHD makes heavy demands on materials technology. High performance electrodes must operate in a high temperature, high velocity, corrosive environment. The channel must also survive the hostile environment. Niobium and titanium are useful for the superconducting magnets.

C. Liquid Metal Handling Technology. Liquid metal handling technology developed for use in MHD applications in which liquid metal is the conducting fluid is also applicable to liquid metal breeder reactors, which can produce fissionable material for use in weapons or in reactors.

D. Plasma Studies. Study of plasma stability problems under various conditions of implosion and explosion can lead to an improved understanding of weapons hydrodynamics.

VI. Advanced Seismic Detection

This technology is critical in the sense that improvements in current seismometer technology, signal processing technology, transmission and reception technology, and integrated circuit technology may allow better detection thresholds and more accurate yield calibrations for underground shots. These improvements could be important in proliferation detection and n-th country device yield estimation.

Currently the big problem to overcome in threshold detection appears to be background noise, and so one might expect that the best chances for improvement would be in signal processing to read through the noise, or in methods to suppress noise.

VII. Satellite Technology

A. Detector Technology. Satellites provide one of our principal means for detecting clandestine nuclear bursts in the atmosphere or in space near the earth in monitoring for treaty compliance, and monitoring for proliferation indications. Substantial amounts of intelligence can be gained about the level of sophistication of weapon design, as well as about the existence and location of a test. This information can be especially important in the case of a first test by an n-th nation. Knowledge of specific performance parameters of satellite detection systems could enable others to design countermeasures to deceive the detection systems and thereby reduce the information available to us in this vital area.

B. Data Transmission and Reception Technology. Data gathered by satellite-borne detector systems is of value only to the extent that it can be transmitted to and received by earth stations. The quantity of data that must be transmitted may be greatly reduced, and the effectiveness of encryption applied to it enhanced by inclusion on the satellite of memory and computing power, which are made possible by microminaturization of components to permit the achievement of sophisticated processing with minimal weight and power requirements.

VIII. Electronics

Every facet of the US defense capability depends upon electronics and most depend specifically on semiconductor electronics. Furthermore electronics has very significantly impacted upon the US production economy. Computerized processing, controlling, and recording have enabled US industry to sustain significant increases in productivity. Electronics technologies are critical because they are in widespread use, are very powerful in solving certain kinds of problems, and control the functions of sensitive defense systems.

A. Semiconductor manufacturing technology. The basic ideas of semiconductor functioning are of course widely known. Integrated circuits are collections of semiconductor elements and passive circuit elements in a single package. The critical factor in these packages is the manufacturing processes

and machinery. Developments in automated fabrication and inspection processes have made possible more reliable, more versatile, smaller packages that can perform a greater array of functions. These fabrication processes are known to some extent world wide, but only a few countries are working at the edge of the technology. Preserving the US lead in these manufacturing technologies is critical to the maintenance of superior equipment for defense and an economic advantage in goods for export.

LX. Safety, Security, and Survivability Technology

A. Reserved.

B. Encryption Technology. Encryption technology is used for the concealment of information. It supports compaction of information to reduce transmission requirements. Encryption is also used to control identification or validation keys in many applications in which it is necessary for equipment to verify the identity of an individual or the validity of an order, before granting access to the individual or obeying the order. Knowledge of advanced encryption technology may both improve an adversary's capabilities in his own use of encryption, to our detriment, and enable him to penetrate our systems, gaining information, gaining access, or causing the execution of false commands.

C. Electronically Assisted Physical Security. Technology relating to the physical protection of weapons facilities should be considered for protection from export. The understanding of this technology provides insight into ways of defeating the protective measures. Extensive R&D relative to protection in the commercial nuclear reactor area has been conducted for several years within the DOE laboratories. Much of this information has been made available through the International Safeguards program to foreign countries and in that regard may be too late to protect. Nevertheless, newer and more sophisticated computer-based techniques for analyzing data from sensors around a protected area are being developed. These techniques reduce false alarm incidence and provide intruder tracking in a way that vastly improves the protective capability of an intrusion detection system. Both the system operational capability and the related devices represent strongly sensitive areas in the overall physical protection of facilities.

D. Weapon Survivability. In defining semiconductor technology that should be protected from export, one extremely innovative area that should be

considered is the application of microprocessors and microcomputers. These powerful control devices are showing up in many of our most modern weapon systems. The manner in which these devices carry out their control and monitoring function could be extremely sensitive since that information could well point to vulnerable aspects of the system. In the area of future application of microcomputers in weapon systems, the area of adaptive control should be considered. The microcomputer contains the mathematical capability to implement complex adaptive algorithms to reprogram a weapon based on measured data on the well-being of critical components or environmental factors. Thus, the microcomputer could well provide the ability for the weapon to sustain substantial damage and still be reprogrammed to accomplish its mission. The Russians have for years developed advanced adaptive control theory and techniques. The microprocessor provides both them and us the opportunity to develop self-healing weapon systems. Applications of microcomputers to such problems should be treated as sensitive technology.

X. Reserved.

References

1. Chapman, Ray E., "Proposed New Approach to Export Control," DOE/OISA memorandum to distribution dated Aug. 14, 1978, unclass.
2. J. Fred Bury, et al., "An Analysis of Export Control of U.S. Technology—A DoD Perspective," a report of the Defense Science Board Task Force on Export of U.S. Technology, written at the request of USDOE, February 1978, unclass.
3. Export Administration Act of 1979, 50 USC APP 2601, Sec. 5D.
4. Herbert Kleinman, "Final Summary Report on Identification of Strategically Significant Technologies," work done at Battelle Columbus sponsored by Dept. of Defense Research and Engineering International Programs Office, January 1978.
5. "A Methodology for the Identification of Militarily Critical Technologies," Meyer Consultants, March 31, 1980, as modified by the (IDA) Critical Technologies Project.

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